- Oxygen is the only gas used in this machine and it is used on Process Configuration 1. **Never use any other process configurations**.

Initializing

- 1. Verify that you have LOGGED IN and Booked this machine.
- 2. RF power should be off. Vacuum pump should already be on.
- 3. Turn on RF power and wait 5 minutes to warm up. RF 'Ready' light will shine when it is warmed.
- 4. Turn on controller and press Reset immediately to cease the alarm.
- 5. Switch the Purge button to Auto. Wait a few minutes for the chamber to pressurize to atmospheric conditions, which will be evident when the door releases.

General Use

- 1. Place Silicon wafer(s) in the quartz holder and gently place them inside the plasma chamber. **Do not touch the thermal probe, which is located inside the chamber**. If your substrate is not a standard Silicon wafer, then gently lay your substrate on the quartz grid inside the chamber. Close the chamber door and lock it.
- 2. <u>Make sure the 'Process 1' knob (located under the power meter) is rotated completely to the left.</u> If the knob is not in this proper position when plasma is lit, then the RF generator will be damaged.
- 3. Make sure all the Auto/Manual switches are set to 'Auto'.
- 4. Make sure **all** the other process configurations are set to Bypass.
- 5. Using the Program 1 settings: Choose the time or temperature switch. Set the value needed to limit the plasma etching.
- 6. Press the start button. The system will automatically pump down. After pump down, listen for a click. This indicates the chamber is prepared for applied power.
- 7. <u>Slowly</u> ramp the 'Process 1' dial to maximum of 600 W in the gage. **It should take 20 seconds to ramp to 600 W**. <u>**Do not exceed 600 W**</u>.
- 8. A timer will sound when the process is complete (when the set time or temperature has been exceeded). Press the Reset button and **return the Process 1 dial completely to the left**. Lift lock on the chamber door. The chamber will automatically vent.
- 9. After the door is released from vacuum, change the Purge switch from Auto to Manual.
- 10. Turn off the controller
- 11. Turn off the RF Generator
- 12. LOG OFF